I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for

Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 28, 2003.

Cathi H. Turner Date of Signature

OIP

OCT 3 0 2003

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Hänsel et al.

Group Art Unit: Not Assigned

Serial No.: 10/660,091

Examiner: Not Assigned

Filed: September 10, 2003

Docket No. 1406/166

Confirmation No.: Not Assigned

FABRICATION METHOD FOR A SEMICONDUCTOR STRUCTURE For:

HAVING A PARTIALLY FILLED TRENCH

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.56, 1.97, and 1.98, applicants' undersigned attorney brings to the attention of the Patent and Trademark Office the documents listed on the attached Form PTO-1449. Copies of the references as well as Form PTO-1449 are attached hereto. This is not to be construed as a representation that a search has been made or that a reference is relevant merely because cited.

Early passage of the subject application to issue is earnestly solicited.

Serial No.: 10/660,091

Although it is believed that no fee is due, the Commissioner is hereby authorized to charge any fees associated with the filing of this Information Disclosure Statement to Deposit Account No. <u>50-0426</u>.

Respectfully submitted,

JENKINS, WILSON & TAYLOR, P.A.

Date: 10-25-03

By:

Richard E. Jenkins

Registration No. 28,428

REJ/cht

Enclosures

Customer No: 25297

		OCT 3 0 2003	102							
FORM PTO-	Attorney Docket No.: 1406/166				Serial No.: 10/660,091					
List of Docum										
	Applicant(s): Hänsel et al.									
	Filing Date: September 10, 2003				G	roup:				
			U.S. P	ATENT DO	CUMENTS					
Examiner Initial	No. Document Number		Date	Name			Class	Subcla	SS	Filing date if Appropriate
	01	US2002/006 6884 A1	06/06/2002	TSAI et a	Al et al.		252	79.1		
	02	6,284,665 B1	09/04/2001	Lill et al.	et al.		438	710		
						·-			:	
			FOREIGN	PATENT	DOCUMEN	TS				
		Document Number	Date	Country N		Na	Name of Patentee or Applicant		Translation Yes No	
	<u> </u>	OTHER DOCUM	IENTS (Includ	ling Author	, Title, Date,	, Per	tinent Paç	ges, Etc.)	
EYAMINED DATE CONSIDERED										

^{*}Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ENKINS

RICHARD E. JENKINS

JEFFREY L. WILSON

ARLES A. TAYLOR, JR.

DAVID P. GLOEKLER

GREGORY A. HUNT

E. ERIC MILLS

BENTLEY J. OLIVE

MICHAEL J. CROWLEY

*CHRIS PERKINS, PH.D.

**JAMES DALY IV, PH.D.

JEFFREY CHILDERS, PH.D.

OF COUNSEL SOROJINI BISWAS

> LICENSED ONLY IN CA "LICENSED ONLY IN KY

patent attorneys

October 28, 2003,



Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450Jon October 28, 2003.

U.S. Patent Application Serial No. 10/660,091 for Re:

FABRICATION METHOD FOR A SEMICONDUCTOR STRUCTURE HAVING A PARTIALLY FILLED TRENCH

Our Ref. No. 1406/166

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

- Information Disclosure Statement (1 page); 1.
- Form 1449 (1 page) (duplicate); 2.
- Copies of cited references (2 references); and 3.
- A return-receipt postcard to be returned to us with the U.S. Patent 4. and Trademark Office filing stamp thereon.

The Commissioner is hereby authorized to charge any fees associated with the filing of this correspondence to Deposit Account No. 50-0426.

Respectfully submitted,

JENKINS, WILSON & TAYLOR, P.A.

Richard E. Jenkins

Registration No. 28,428

REJ/cht **Enclosures**

Customer No: 25297